

14002-7



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	E ' ED 4
	:	Examiner: TBA
STEPHEN Y. CHOU, et al.)	Group Art Unit: 1765
A 11 - 41 - 1 NJ - 10/706 757	;	Group Art Offic. 1703
Application No.: 10/706,757	,	
Filed: November 12, 2003	,	
r fied. November 12, 2005	:	
For: COMPOSITIONS AND PROCESSES)	
FOR NANOIMPRINTING	:	March 10, 2005

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449. In accordance with an Official Gazette notice dated August 5, 2003, copies of cited U.S. patents and U.S. published applications are not enclosed. Copies of the other cited references, however, are enclosed.

It is respectfully requested that the PTO-1449 form be initialed and returned, indicating that the listed references have been considered.

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Applicants' undersigned attorney may be reached by telephone at (973) 597-

2500. All correspondence should continue to be directed to our address listed below.

Respectfully submitted,

Glen E. Books, Esq.

Registration No. 24,950

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INFORMATION DISCLOSURE CITATION					14002-7 Applicant(s) Stephen Y. Chou, et al.					
(Use several sheets if necessary)					Stephen Y. Filing Date November 1	Group Art Unit 1765				
	М	AR 1 5 2005 Ju		U.S. PATENT	DOCUMENTS					
*EXAMINER INITIAL REF DEPUMENT NUMBER					NAME			SUBCLASS	FILING DA	
		04/13/93		Reid et al.		523	516			
	2001/0040145		11/15/01		Willson et al.		216	52		
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			FC	REIGN PATEN	T DOCUMENTS				TDANCI A	TION
	REF	DOCUMENT NUMBER		BLICATION DATE	COUNTRY	CLASS	SUBCLASS		TRANSLA' Yes	No
-		WO 02/031		0-01-02		G03F	7/00			
	62214531		2	1-09-87	G11B		7/24			
		OTHER	DOCUMENTS	(Including Auth	or, Title, Date, Perti	inent Pages, E	tc.)			
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Examiner					Date Considered					
EXAMINER: Initial conformance and i	l if citation not consider PTO-1449)	n considered, wh lered. Include co	ether or not ci py of this form	tation is in co with next com	nformance with M munication to app	IPEP Section olicant.	609; Drav	v line through	n citation if	not in

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Date of Submission: March , 2005 Method of Submission: 37 C.F.R. § 1.8 U.S. Appln. No.: 10/706,757 Atty Docket No.: 14002-7

The U.S. Patent and Trademark Office acknowledges, and has stamped hereon, the date of the receipt of the items listed below:

(1) Information Disclosure Statement and PTO-1449 form (3 sheets)
 (2) 8 Cited References

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